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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hisashi NAKAMURA et al.**

Group Art Unit: **2675**

Application Number: **10/073,959**

Examiner: **Srilakshmi K. Kumar**

Filed: **February 14, 2002**

Confirmation Number: **8711**

For: **LIQUID CRYSTAL PROJECTOR COOLING SYSTEM DEPENDENT ON AIR
PRESSURE AND TEMPERATURE VARIABLES (AS AMENDED)**

Attorney Docket Number: **042288**

Customer Number: **38834**

REQUEST FOR STATUS

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

November 30, 2006

Sir:

The undersigned attorney requests the status of the above-identified application.

The application was filed on **February 14, 2002** in the U.S. Patent and Trademark Office. To date, no Office Action has been received by Applicant. Applicant(s) respectfully request(s) the status of the above-referenced application.

If any fees are required in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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